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Bib Data Sheet

CONFIRMATION NO. 7432

<b>SERIAL NUMBER</b> 10/010,850	<b>FILING DATE</b> 12/05/2001 <b>RULE</b>	<b>CLASS</b> 134	<b>GROUP ART UNIT</b> 1746	<b>ATTORNEY DOCKET NO.</b> SD6957S97604	
<b>APPLICANTS</b> Peggy J. Clews, Tijeras, NM; Seethambal S. Mani, Albuquerque, NM;					
<b>** CONTINUING DATA *****</b> <i>none</i>					
<b>** FOREIGN APPLICATIONS *****</b> <i>none</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 01/29/2002</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature <i>Binh Tran</i> Initials		<b>STATE OR COUNTRY</b> NM	<b>SHEETS DRAWING</b> 1	<b>TOTAL CLAIMS</b> 18	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> Sandia National Laboratories P. O. Box 5800 - MS-0161 Albuquerque, NM 87185-0161					
<b>TITLE</b> Selective etchant for oxide sacrificial material in semiconductor device fabrication					
<b>FILING FEE RECEIVED</b> 740	<b>FEES:</b> Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other <input type="checkbox"/> Credit		